

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	IS&R	L1	483	(310/309).CCLS.	USPAT	2002/11/13 14:51	
2	IS&R	L2	192	(310/309).CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2002/11/13 14:57	
3	BRS	L3	3	(micromechanical or mems or microelectromechanical adj2 (resonator or oscillator or vibrator) and submicron	USPAT	2002/11/13 15:00	
4	BRS	L4	3	(micromechanical or mems or microelectromechanical adj2 (resonator or oscillator or vibrator) and submicron	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2002/11/13 15:02	
5	BRS	L5	40	(micromechanical or mems or microelectromechanical adj2 (resonator or oscillator or vibrator) not 14	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2002/11/13 15:05	
6	BRS	L6	53	(micromechanical or mems or microelectromechanical adj2 (resonator or oscillator or vibrator) not 13	USPAT	2002/11/13 15:06	